Momentary High-Z Gate Driving (MHZGD) at Miller Plateau for IGBT Load Current Estimation from Gate Driver

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Abstract—To eliminate a load current (IL) sensor required to determine optimum gate driving parameters of a digital gate driver for IGBTs and to estimate IL from the gate driver, a momentary high-Z gate driving (MHZGD) method is proposed. In MHZGD, the output voltage (V_{OUT}) of the gate driver is measured at Miller plateau when the gate driving current (I_G) is zero for a short time (1 µs in this paper), and *I*_L is estimated from the measured V_{OUT} . MHZGD is suitable for the digital gate driver, because the $I_{\rm L}$ estimation is not affected by $I_{\rm G}$, and has the advantage of not affecting the switching operation of IGBT. In the double pulse test of IGBT at 300 V, by using one-point calibration at $I_{\rm L}$ = 20 A at 25 °C, the measured $I_{\rm L}$ estimation errors of three IGBTs in the range from 5 A to 80 A are within + 7.7 % / - 7.0 % at 25 °C, 75 °C, and 125 °C, which suggests that MHZGD can estimate IL with acceptable error against IGBT and temperature variations.

Keywords-digital gate driver, IGBT, load current, estimation

I. INTRODUCTION

Active gate driving of IGBTs, where the gate driving current (I_G) is dynamically controlled during the turn-on/off transients, is a promising technology to solve the conventional trade-off between the switching loss and the current or voltage overshoot of IGBTs. Digital gate drivers (DGDs) [1] are useful for the active gate driving, because I_G is programmable with gate driving parameters using a software. In DGDs, however, gate driving parameters require information on load current (I_L) and junction temperature (T_J), because the optimum parameters depend on I_L and T_J [2]. Since adding a current sensor (e.g., current transformer, shunt resistor [3-4], and Rogowski coil [5-7]) to measure I_L is costly, I_L estimation method, which can be integrated on DGD IC, is preferable in terms of cost reduction.

Fig. 1 shows a circuit schematic of a gate driver and an IGBT. I_L can be estimated by Miller plateau voltage of the internal gate-emitter voltage ($V_{GE,INT}$) of IGBT, because the plateau voltage depends on I_L [8]. The target of this work is to estimate I_L from the output voltage (V_{OUT}) of the gate driver



Fig. 1. Circuit schematic of gate driver and IGBT.

without depending on I_G . V_{OUT} and $V_{GE,INT}$, however, are not equal due to $I_G(R_{G,INT} + R_{G,EXT})$ drop, where $R_{G,INT}$ and $R_{G,EXT}$ are the internal gate resistance of IGBT module and the external gate resistance, respectively. In [8], the relationship between I_L and the external gate-emitter voltage ($V_{GE,EXT}$) of IGBT module depends on I_G , which is not acceptable in DGDs, because I_G dynamically changes in DGDs. In [9], I_L is estimated from I_G , which cannot be used in the currentsource based DGDs [1], because I_G is controlled by digital inputs and does not depend on I_L . To solve the problems, in this paper, a momentary high-Z gate driving (MHZGD) method is proposed to estimate I_L from V_{OUT} without depending on I_G .

II. PROPOSED MOMENTARY HIGH-Z GATE DRIVING (MHZGD)

Figs. 2 and 3 show waveforms of a conventional gate driving and the proposed MHZGD at turn-on and turn-off of IGBT, respectively. In the conventional gate driving, V_{OUT} at the Miller plateau is not equal to $V_{\text{GE,INT}}$ due to I_{G} ($R_{\text{G,INT}}$ + $R_{G,EXT}$) drop. In MHZGD, however, I_G is zero during t_2 (1 µs in this paper) and the operation starts after turn-on or before turn-off. Zero $I_{\rm G}$ for a short time is the origin of name of MHZGD. In this work, the zero $I_{\rm G}$ is achieved using the current-source based DGD [1]. Even if the current-source based DGD is not available, any gate driver can implement MHZGD if a switch is added between the output of the gate driver and the gate of IGBT, and the switch is turned off for a short time. The period of t_2 must be after the switching of the collector current ($I_{\rm C}$) and the collector-emitter voltage ($V_{\rm CE}$) at turn-on (Fig. 2) and before the switching of $I_{\rm C}$ and $V_{\rm CE}$ at turnoff (Fig. 3) to avoid the increase of switching loss, and must be within the Miller plateau of $V_{GE,INT}$. During t_2 , V_{OUT} is equal to $V_{\text{GE,INT}}$ because of zero I_{G} , and this V_{OUT} is defined as $V_{\text{OUT,MHZ}}$. Therefore, in MHZGD, I_{L} can be estimated from



Fig. 2. Waveforms of conventional gate driving and proposed MHZGD at turn-on of IGBT.



Fig. 3. Waveforms of conventional gate driving and proposed MHZGD at turn-on of IGBT.

 $V_{\text{OUT,MHZ}}$ (= $V_{\text{GE,INT}}$). The measurement of $V_{\text{OUT,MHZ}}$ can be done with an A/D converter, which can be integrated on DGD IC. V_{OUT} just before the period of t_2 is defined as $V_{\text{OUT,CONV}}$.

Fig. 4 shows the photo of the measurement setup of the double pulse test of the IGBT module (2MBI100VA-060-50, 600 V, 100 A) at 300 V to demonstrate MHZGD. The currentsource based DGD IC [1] drives the low side of the IGBT module. $R_{G,EXT}$ is zero. In this paper, I_L estimations at different IGBT modules, T_J 's, and I_G 's are discussed. Figs. 5 (a) and (b) show the measured waveforms at $I_{\rm L}$ = 50 A, $T_{\rm J}$ = 25 °C, and t_2 $= 1 \mu s$ during the turn-on and turn-off of IGBT, respectively. V_{OUT MHZ} generated by MHZGD is clearly observed. Please note that MHZGD has no effect on the switching loss and overshoots of $I_{\rm C}$ and $V_{\rm CE}$. Figs. 6 (a) and (b) show the measured V_{OUT} waveforms of $I_{\text{L}} = 5$ A, 50 A and 80 A at $T_{\text{J}} =$ 25 °C during the turn-on and turn-off of IGBT, respectively. $V_{\text{OUT,MHZ}}$ increases with increasing I_{L} . Figs. 7 (a) and (b) show the measured V_{OUT} waveforms of two different I_{G} 's at $I_{L} = 50$ A and $T_{\rm J} = 25$ °C during the turn-on and turn-off of IGBT, respectively. Please note that $V_{OUT,MHZ}$'s of the two curves are the same independent of I_{G} . Figs. 8 (a) and (b) show the measured IL dependence of VOUT, CONV and VOUT, MHZ of two different I_{G} 's at $T_{J} = 25$ °C during the turn-on and turn-off of IGBT, respectively. $V_{\text{OUT,CONV}} - V_{\text{OUT,MHZ}}$ is 0.68 V at $I_{\text{G}} = 78$ mA during the turn-on and VOUT,MHZ - VOUT,CONV is 0.68 V at $I_{\rm G}$ = 78 mA during the turn-off, which are reasonably explained by $I_{\rm G} \times R_{\rm G,INT} = 78 \text{ mA} \times 9 \Omega = 0.70 \text{ V}$. Both VOUT, CONV and VOUT, MHZ depend on IL. VOUT, CONV depends on $I_{\rm G}$, while $V_{\rm OUT,MHZ}$ does not depend on $I_{\rm G}$, which clearly shows that proposed MHZGD estimates $I_{\rm L}$ independent of $I_{\rm G}$. As expected, the curve of $V_{OUT,MHZ}$ in Fig. 8 (a) matches the curve of V_{OUT,MHZ} in Fig. 8 (b) and the proposed MHZGD works for



Fig. 4. Photo of measurement setup of double pulse test of IGBT module.



Fig. 5. Measured waveforms at $I_L = 50$ A, $T_J = 25$ °C, and $t_2 = 1$ µs. (a) Turn-on. (b) Turn-off.



Fig. 6. Measured V_{OUT} waveforms of $I_{\text{L}} = 5$ A, 50 A and 80 A at $T_{\text{J}} = 25$ °C. (a) Turn-on. (b) Turn-off.



Fig. 7. Measured V_{OUT} waveforms of two different I_{G} 's at $I_{\text{L}} = 50$ A and $T_{\text{J}} = 25$ °C. (a) Turn-on. (b) Turn-off.



Fig. 8. Measured I_L dependence of $V_{OUT,CONV}$ and $V_{OUT,MHZ}$ of two different I_G 's at $T_J = 25$ °C. (a) Turn-on. (b) Turn-off.

both turn-on and turn-off. Therefore, only the turn-on case will be discussed in the following sections.

III. LOAD CURRENT ESTIMATION USING MHZGD

In this section, the proposed I_L estimation method using MHZGD is explained. Eq. (1) shows the I_C model [10] based on alpha-power law model of MOSFET [11], where $k(T_J)$ is the T_J -dependent constant, $V_{TH}(T_J)$ is the T_J -dependent threshold voltage of IGBT, and α ($1 < \alpha < 2$) is a constant. Substituting $I_C = I_L$ and $V_{GE,INT} = V_{OUT,MHZ}$ into Eq. (1), Eq. (2) is obtained. Eq. (3) shows T_J dependence of $k(T_J)$ [12], where T_R is the room temperature (25 °C) whose unit is absolute temperature, $k(T_R)$ is $k(T_J)$ at $T_J = T_R$, and β ($\beta > 0$) is a constant. Eq. (3) shows T_J dependence of $V_{TH}(T_J)$ [12], where $V_{TH}(T_R)$ is $V_{TH}(T_J)$ at $T_J = T_R$, and γ ($\gamma > 0$) is a constant. Substituting Eqs. (3) and (4) into Eq. (2), Eq. (5) is obtained.

$$\begin{split} &I_{\rm C} = k(T_{\rm J}) \Big\{ V_{\rm GE, \rm INT} - V_{\rm TH}(T_{\rm J}) \Big\}^{\alpha} \quad (1) \\ &I_{\rm L} = k(T_{\rm J}) \Big\{ V_{\rm OUT, \rm MHZ} - V_{\rm TH}(T_{\rm J}) \Big\}^{\alpha} \quad (2) \\ &k(T_{\rm J}) = k(T_{\rm R}) \bigg(\frac{T_{\rm J}}{T_{\rm R}} \bigg)^{-\beta} \quad (3) \\ &V_{\rm TH}(T_{\rm J}) = V_{\rm TH}(T_{\rm R}) - \gamma \big(T_{\rm J} - T_{\rm R}\,\big) \quad (4) \\ &k(T_{\rm R}) \bigg(\frac{T_{\rm J}}{T_{\rm R}} \bigg)^{-\beta} \Big\{ V_{\rm OUT, \rm MHZ} - \big\{ V_{\rm TH}(T_{\rm R}) - \gamma \big(T_{\rm J} - T_{\rm R}\,\big) \big\} \Big\}^{\alpha} \end{split}$$

(5)

Fig. 9 shows an overview of the proposed $I_{\rm L}$ estimation method using MHZGD. When the measured $V_{\rm OUT,MHZ}$ and $T_{\rm J}$ are given, $I_{\rm L}$ is estimated using Eq. (5). $k(T_{\rm R})$, $V_{\rm TH}(T_{\rm R})$, α , β , and γ are determined by the calibration method. Fig. 10 shows the calibration method for finding the values of five parameters. For unknown IGBTs, five parameters are determined by performing a five-point calibration from step 1 to step 5 only for the first one IGBT, and one parameter $(V_{\rm TH}(T_{\rm R}))$ is determined by performing a one-point calibration from step 6 to step 7 for the second and subsequent IGBTs. In Step 1, three $V_{\rm OUT,MHZ}$'s are measured at three different $I_{\rm L}$'s at $T_{\rm J} = T_{\rm R} = 25$ °C. In Step 2, $k(T_{\rm R})$, $V_{\rm TH}(T_{\rm R})$, and α are determined by the curve fitting [13] as shown in Fig. 11 (a). In Step 3, two $V_{\rm OUT,MHZ}$'s are measured at two different $I_{\rm L}$'s at $T_{\rm J} = 125$ °C. In Step 4, $k(T_{\rm J} = 125$ °C) and $V_{\rm TH}(T_{\rm J} = 125$ °C)



Fig. 9. Overview of proposed I_L estimation method using MHZGD.

 $I_{\rm L} =$







Fig. 11. Example of determination of parameters. (a) Step 2 in Fig. 10. (b) Step 4. (c) and (d) Step 5.

are determined by the curve fitting as shown in Fig. 11 (b). In Step 5, β and γ are determined by the curve fitting as shown in Figs. 11 (c) and (d). This completes the five-point calibration only for the first one IGBT. For the second and subsequent IGBTs, the same $k(T_R)$, α , β , and γ as the first one IGBT are used, and the one-point calibration from step 6 to step 7 are required to determine $V_{TH}(T_R)$ for each IGBT to account for manufacturing variations between IGBTs. In Step 6, one $V_{OUT,MHZ}$ is measured at any I_L at $T_J = T_R = 25$ °C. In Step 7, $V_{TH}(T_R)$ is determined by the curve fitting. Different from the model-based prediction which requires eight I_L measurements [8], the proposed estimation requires only one I_L measurement.

Table I shows the measurement conditions and the calibrated parameters obtained by the calibration method shown in Fig. 10. IGBT1 indicates the first one IGBT, and IGBT2,3 show the second and third IGBTs. In IGBT1, the five parameters are calibrated, while the one parameter ($V_{\text{TH}}(T_R)$) is calibrated in IGBT2 and IGBT3. Fig. 12 shows the measured and estimated I_L dependence of $V_{\text{OUT,MHZ}}$ of IGBT1 at $T_J = 25$ °C to 125 °C in 10 °C increments. The estimated

Measured		Calibrated	Parameters					
conditions (<i>T</i> _J , <i>I</i> _L)	Sample	parameters	<i>V</i> _{TH} (<i>T</i> _R) [V]	k(T _R) [A/Vα]	α	β	γ [mV/K]	
(25°C, 5A), (25°C, 20A), (25°C, 80A), (125°C, 5A), (125°C, 80A)	IGBT1	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \alpha, \gamma, \beta$	6.64	13.4	1.80	1.48	7.56	
(25°C, 5A)	IGBT2	$V_{\rm TH}(T_{\rm R})$	6.83					
	IGBT3	V _{TH} (T _R)	6.87					

TABLE I. MEASUREMENT CONDITIONS AND CALIBRATED PARAMETERS IN ONE-POINT CALIBRATION



Fig. 12. Measured and estimated I_L dependence of $V_{OUT,MHZ}$ of IGBT1 at $T_J = 25$ °C to 125 °C in 10 °C increments.



Fig. 13. IL estimation error in Fig. 12.

curves are calculated using Eq. (5) and Table I. Fig. 13 shows the $I_{\rm L}$ estimation error in Fig. 12. $I_{\rm L}$ estimation error in IGBT1 in the range of 5 A to 80 A and $T_{\rm J} = 25$ °C to 125 °C is within + 5.2 % / - 4.6 %, which supports that $T_{\rm J}$ dependence of $I_{\rm L}$ is reasonably expressed in Eq. (5) with β and γ . Fig. 14 shows the measured and estimated $I_{\rm L}$ dependence of $V_{\rm OUT,MHZ}$ of IGBT1 to IGBT3 at $T_{\rm J} = 25$ °C, 75 °C, and 125 °C. Fig. 15 shows the $I_{\rm L}$ estimation error in Fig. 14. Please note that $I_{\rm L}$ estimation errors at $I_{\rm L} = 20$ A in IGBT2 and IGBT3 are 0 %, because the one-point calibration is done at $I_{\rm L} = 20$ A. $I_{\rm L}$ estimation error of three IGBTs in the range of 5 A to 80 A at $T_{\rm J} = 25$ °C, 75 °C, and 125 °C is within + 7.7 % / - 7.0 %, which supports that the manufacturing variations between IGBTs are reasonably expressed in Eq. (5) with different $V_{\rm TH}(T_{\rm R})$ for each IGBT shown in Table I.



Fig. 14. Measured and estimated I_L dependence of $V_{\text{OUT,MHZ}}$ of IGBT1-3 at T_J = 25 °C, 75 °C, and 125 °C.



Fig. 15. IL estimation error in Fig. 14.

IV. DISCUSSION ON NUMBER OF CALIBRATION POINTS

In the previous section, the one-point calibration is applied to IGBT2 and IGBT3, and $I_{\rm L}$ estimation error is within + 7.7 % / - 7.0 % as shown in Fig. 15. Increasing the number of points in the calibration can be considered as a way to reduce the $I_{\rm L}$ estimation error. When the number of calibration points is increased, however, the cost of the calibration for each IGBT will increase. To find out if increasing the number of points in the calibration would decrease the $I_{\rm L}$ estimation error, the relationship between the number of points in the calibration and the $I_{\rm L}$ estimation error is investigated in this section. Table II shows the measurement conditions and calibrated parameters obtained by five-point, four-point, and two-point calibrations. In the five-point calibration, the five parameters ($k(T_{\rm R})$, $v_{\rm TH}(T_{\rm R})$, α , β , and γ) for each IGBT are determined by

Measured		Calibrated parameters	Parameters					
conditions (<i>T</i> _J , <i>I</i> _L)	Sample		V _{TH} (<i>T</i> _R) [V]	k(T _R) [A/Vα]	α	β	γ [mV/K]	
(25°C, 5A), (25°C, 20A), (25°C, 80A), (125°C, 5A), (125°C, 80A)	IGBT1	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \alpha, \gamma, \beta$	6.64	13.4	1.80	1.48	7.56	
	IGBT2	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \alpha, \gamma, \beta$	6.86	14.3	1.74	1.37	7.07	
	IGBT3	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \alpha, \gamma, \beta$	6.92	14.7	1.71	1.21	7.41	

TABLE II. MEASUREMENT CONDITIONS AND CALIBRATED PARAMETERS.

(a) Five-point calibration.

Measured		Calibrated	Parameters					
conditions (<i>T</i> _J , <i>I</i> _L)	Sample	parameters	<i>V</i> _{TH} (<i>T</i> _R) [V]	<i>k</i> (<i>T</i> _R) [A/V ^α]	α	β	γ [mV/K]	
(25°C, 5A), (25°C, 20A), (25°C, 80A), (125°C, 5A), (125°C, 80A)	IGBT1	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \alpha, \gamma, \beta$	6.64	13.4	1.80	1.48	7.56	
(25°C, 5A),	IGBT2	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \gamma, \beta$	6.82	13.1		1.42	7.18	
(25°C, 80A), (125°C, 5A), (125°C, 80A)	IGBT3	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \gamma, \beta$	6.85	12.9		1.28	7.56	

(b) Four-point calibration.

Measured		Calibrated	Parameters					
conditions (<i>T</i> _J , <i>I</i> _L)	Sample	parameters	V _{TH} (<i>T</i> _R) [V]	<i>k</i> (<i>T</i> _R) [A/V <i>α</i>]	α	β	γ [mV/K]	
(25°C, 5A), (25°C, 20A), (25°C, 80A), (125°C, 5A), (125°C, 80A)	IGBT1	$V_{\text{TH}}(T_{\text{R}}), k(T_{\text{R}}), \alpha, \gamma, \beta$	6.64	13.4	13.4		7.56	
(25°C, 5A), (25°C, 80A)	IGBT2	$V_{\rm TH}(T_{\rm R}), k(T_{\rm R})$	6.82	13.1				
	IGBT3	$V_{\rm TH}(T_{\rm R}), k(T_{\rm R})$	6.85	12.9				

(c) Two-point calibration.

the calibration method shown in Fig. 10. In the four-point calibration, the five parameters are calibrated in IGBT1, while the four parameter ($k(T_R)$, $V_{TH}(T_R)$, β , and γ) is calibrated in IGBT2 and IGBT3. In the two-point calibration, the five parameters are calibrated in IGBT1, while the two parameter ($k(T_R)$ and $V_{TH}(T_R)$) is calibrated in IGBT2 and IGBT3.

Fig. 16 shows the I_L estimation error of three IGBTs at T_J = 25 °C, 75 °C, and 125 °C in five-point, four-point, and twopoint calibrations. Table III shows a summary of the I_L estimation error in four different calibration methods. When the number of calibration points is increased from one to five, the range of the I_L estimation error decreases from 14.7 % to 11.1 %. The five-point calibration, however, requires five measurements at T_J = 25 °C and 125 °C for each IGBT, which is not practical, because the calibration cost is high. Therefore, in conclusion, the one-point calibration is recommended and proposed in this paper. In Table III, it is not reasonable at first glance for the error range of two-point calibration to be larger than that of one-point calibration. The reason is that the two-point calibration is done at $I_L = 5$ A and 80 A as shown in Fig. 16 (c) and the one-point calibration is done at $I_L = 20$ A as shown in Fig. 15, and the I_L estimation error range of the one-point calibration is accidentally small in this case.

V. CONCLUSIONS

The proposed MHZGD, which can be integrated on DGD IC, estimated $I_{\rm L}$ from $V_{\rm OUT,MHZ}$ without depending on $I_{\rm G}$, and $I_{\rm L}$ estimation errors of three IGBTs were within + 7.7 % / - 7.0 % using the one-point calibration in the range of 5 A to 80 A at 25 °C, 75 °C, and 125 °C. When the number of calibration points is increased from one to five, the $I_{\rm L}$ estimation error range decreases from 14.7 % to 11.1 %. The one-point calibration, however, is recommended, because the cost of the five-point calibration at $T_{\rm J}$ = 25 °C and 125 °C for each IGBT is excessive.



Fig. 16. I_L estimation error of IGBT1-3 at T_J = 25 °C, 75 °C, and 125 °C in (a) five-point, (b) four-point, and (c) two-point calibrations.

TABLE III.	SUMMARY	OF I_L	ESTIMATION	ERROR	in Fo	our I	DIFFER	ENT
CALIBRATION	METHODS							

Calibration	I _L estimation error						
method	Max	Min	Max – Min				
5-point	+5.7%	-5.4%	11.1%				
4-point	+5.2%	-6.6%	11.8%				
2-point	+6.6%	-9.0%	15.6%				
1-point	+7.7%	-7.0%	14.7%				

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